JAN 3 0 20

Docket No.

209284US9

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Zhiyi YU, et al.

SERIAL NO: 09/842,734

GAU: 2811

FILED:

April 26, 2001

**EXAMINER: HU, SHOUXIANG** 

FOR:

STRUCTURE AND METHOD FOR FABRICATING SEMICONDUCTOR STRUCTURES AND

DEVICES USING BINARY METAL OXIDE LAYERS

## **EXPRESS ABANDONMENT UNDER 37 CFR 1.138**

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

Applicant(s) wish to disclose the following information.

Express Abandonment

Applicant's Representative requests that the above-identified application be expressly abandoned as of the filing date of this paper.

☐ Express Abandonment in Favor of a Continuing Application

Applicant's Representative requests that the above-identified application be expressly abandoned as of the filing date accorded the continuing application filed herewith.

Petition for Express Abandonment to Avoid Publication under 37 C.F.R. 1.138(c)

Applicant's Representative hereby petitions to expressly abandon the above-identified application under 37 CFR 1.138(c) to avoid publication.

The required petition fee under 37 CFR 1.17(h) of \$130.00 is enclosed herewith by credit card payment form and any further charges may be made against the Attorney of Record's Deposit Account No. <u>15-0030</u>. A duplicate copy of this sheet is enclosed.

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)1 FC:1464

130.00 GP

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.

Richard L. Treanor

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TPE DOCKET NO: 209284US99

## IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

ZHIYI YU, ET AL.

: EXAMINER: HU, SHOUXIANG

SERIAL NO: 09/842,734

FILED: APRIL 26, 2001

: GROUP ART UNIT: 2811

FOR: STRUCTURE AND METHOD FOR FABRICATING SEMICONDUCTOR STRUCTURES AND DEVICES USING BINARY METAL OXIDE LAYERS

## **REQUEST FOR REFUND**

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

Applicants request a refund in the amount of \$130.00 for the Express Abandonment Under 37 CFR 1.138 fee paid in error on January 30, 2006, in the above-identified application. Applicants request a refund as the fee is only required with a petition to avoid publication of the application.

Please credit the refund to our Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND, MAJER & NEUSTADT, P.C.

Richard L. Treanor Attorney of Record Registration No. 36,379

Customer Number 22850

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